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CONFIRMATION NO. 3769

SERIAL NUMBER 10/756,830	FILING DATE 01/14/2004 RULE	CLASS 438	GROUP ART UNIT 2891	ATTORNEY DOCKET NO. 55071-329
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APPLICANTS

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** CONTINUING DATA *****

This appln claims benefit of 60/439,807 01/14/2003 *CME*

** FOREIGN APPLICATIONS *****

*NONE
CME*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 04/15/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 15	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i>	Initials		

ADDRESS

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TITLE

Method and apparatus for providing optical proximity features to a reticle pattern for deep sub-wavelength optical lithography

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of
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